

Monday Morning					
	7 <sup>th</sup> IVM	5 <sup>th</sup> ETCHC			
9h00m	<b>Opening Ceremony</b>				
9h10m	<b>Plenary session 1</b> J.L. de Segovia, Instituto de Ciencia de Materiales de Madrid (former IUVSTA President) "History of Vacuum"				
10h00m	<b>Plenary session 2</b> G. Fortunato, Flexidis and IMM- CNR, Italy "Low temperature polysilicon TFTs on polyimide substrates for flexible electronics"				
11h00m	<b>Coffee break</b>				
11h20m	<b>7IVM Oral 01</b> <u>C. Petitjean, D. Horwat and J.F. Pierson</u> "Structure and properties of sputtered Ag-Cu-O films: effect of the oxygen flow rate and of the target chemical composition"	<b>7IVM Oral 06</b> <u>Baogui Shi, John L.Sullivan and Sayah O.Saied</u> "Sputtered Carbon coating Characterization and Bias voltage effect"	<b>5ETCHC Invited 01</b> <u>Ramón Escobar Galindo, R. Gago, A. Lousa, C .Palacio, J.M. Albelia, Autonoma University of Madrid, Spain</u> "Advanced characterization of nanometer multilayers: depth profiling comparison of RBS, SIMS, XPS and GDOES"		
11h40m	<b>7IVM Oral 02</b> <u>C.A.A. Ghuman, A.M.C. Moutinho, V. Vassilenko and O.M.N.D. Teodoro</u> "Investigation on renal stone analysis with ToF-SIMS"	<b>7IVM Oral 07</b> <u>John L.Sullivan</u> "Physical properties of ultra fast deposited micro and nano thickness amorphous hydrogenated carbon films for medical devices and prostheses"			
12h00m	<b>7IVM Oral 03</b> <u>Hugo Águas, Sergej A. Filonovich, Iwona A. Bernacka, Elvira Fortunato and Rodrigo Martins</u> "Highly conductive p-type nanocrystalline silicon films deposited by rf-PECVD using silane and trimethylboron mixtures at high pressure"	<b>7IVM Oral 08</b> <u>A. Cavaleiro</u> Adhesion problems related with deficient ion cleaning of the substrates	<b>5ETCHC Invited 02</b> <u>Luis Rebouta, F. Vaz(a), S. Carvalho and K. Shein, Department of Physics, Universidade do Minho, Portugal</u> "Superhard nanostructured coatings: structure and properties relations"		
12h20m	<b>7IVM Oral 04</b> <u>S. Carmona, C. Palacio, O. Sánchez, M. Aguilar, C. Falcony, J. Guzmán, M. Canseco, G. Alarcón and M. García</u> "Interface properties of Al <sub>2</sub> O <sub>3</sub> thin films deposited on c-Si by pulsed ultrasonic sprayed pyrolysis"	<b>7IVM Oral 09</b> <u>Manuel Evaristo, Tomas Polcar and Albano Cavaleiro</u> "Synthesis and structural properties of W–Se–C coatings deposited by PVD in reactive and non-reactive processes"			
12h40m	<b>7IVM Oral 05</b> <u>António Vieira, Maria Machado Angelo Yializis and Gordon Goodyear</u> "High speed surface functionalization of woven and non woven textiles"	<b>7IVM Oral 10</b> <u>A.L. Shaula, V.A. Kolotygin, J.C. Oliveira, V.V. Kharton and A.A. Cavaleiro</u> "Protective YSZ-based thin films deposited by RF magnetron sputtering"	<b>5ETCHC Oral 01</b> <u>Alberto Alberdi, Beatriz Díaz, Marcos Marín, Josu Goikoetxea, Unai Ruiz de Gopegui and Borja Coto</u> "Synthesis and Properties of Silicon-Aluminium Based Nanocomposite Coatings"		
13h00m	<b>Lunch</b>				

Monday Afternoon		
	7 <sup>th</sup> IVM	5 <sup>th</sup> ETCHC
14h20m	<b>Plenary session 3</b> Ron Naaman, The Weizmann Institute of Science, Israel "Cooperative Molecular Field Effect- A Source for New Electronic Properties at Interfaces"	
15h20m	<b>7IVM Invited 01</b> <u>Pierre Jamoton</u> , Facility Department, Low Temperatures Laboratory, Centre Spatial de Liege, Université de Liège "Planck Cryogenic Testing in CSL Premises, Helium Partial Pressure Management"	<b>5ETCHC Invited 03</b> <u>Tomas Polcar</u> , M. Evaristo, and A. Cavaleiro, University of Coimbra, Portugal "Transition metal dichalcogenides alloyed with carbon: a new class of self-lubricating coating"
16h00m	<b>Coffee break</b>	
16h20m	<b>7IVM Invited 02</b> <u>Wolfgang Jitschin</u> , University of Applied Sciences Giessen-Friedberg, Germany "Precise flow measurement of arbitrary gas species over a wide range"	<b>5ETCHC Invited 04</b> <u>Johan Böhlmärk</u> , Grzegorz Greczynski, Rainer Cremer, Yutao Pei, and Ulf Helmersson, CEO Chemfilt Ionspattering AB Linköping, Sweden "High Power Impulse Magnetron Sputtering – an overview of history, properties and current status"
17h00m	<b>7IVM Oral 11</b> I. Catarino, D. Martins, J. Afonso, L. Duband and <u>G. Bonfait</u> "H <sub>2</sub> and Ne Gas Gap Heat Switches"	<b>5ETCHC Oral 02</b> <u>Alderson Neira</u> , Federico Sequeda, Alexander Ruden and Juan M. González "PVD Nitride Hard Coatings Production on Chromium Based Tool Steel Substrates"
17h20m	<b>7IVM Invited 03</b> <u>Lluis Miralles</u> , CELLS Engineering Division, Barcelona, Spain "ALBA Spanish Synchrotron Light Source- Vacuum System Status"	<b>5ETCHC Invited 05</b> <u>Wolfgang Diehl</u> , Fraunhofer-Institut für Schicht- und Oberflächentechnik, Braunschweig, Germany "Hard coatings produced by plasma processes – technology and recent applications"

Tuesday Morning		
	7 <sup>th</sup> IVM	5 <sup>th</sup> ETCHC
9h00m	<b>Plenary session 4</b> Geoff Thornton, London Centre for Nanotechnology, University College London, UK “Nanoscale science on metal oxide surfaces”	
10h00m	<b>7IVM Invited 04</b> <u>João Pedro Conde</u> , Department of Chemical and Biological Engineering, Instituto Superior Técnico, Lisbon, Portugal “Thin-film silicon MEMS”	<b>5ETCHC Invited 06</b> <u>F. Bénédic</u> , D. Monéger, G. Lombardi, K. Hassouni, A. Michau, M.B. Assouar, O. Elmazria, A. Gicquel, P. Alnot, Laboratoire d'Ingénierie des Matériaux et des Hautes Pressions, CNRS, Université Paris 13, France “Nanocrystalline diamond films: from growth to applications”
10h40m	<b>7IVM Oral 12</b> <u>P. Alpuim</u> , P.F. Rocha, S. Lanceros-Mendez, E.S. Marins, I.G. Trindade, J.G. Rocha and M.A. Carvalho “Ultra-Sensitive Shape Sensor Test Structures Based on Piezo-Resistive Doped Nanocrystalline Silicon”	<b>5ETCHC Oral 03</b> J. Romero, L.A. Yate, L. Martínez de Olcoz, J. Esteve, C. Gomez-Aleixandre and A. Lousa “Amorphous carbon/Cr <sub>3</sub> C <sub>2</sub> nanocomposite thin films”
11h00m	<b>Coffee break</b>	
11h20m	<b>7IVM Invited 05</b> R. Caillard, G. Otero, L. Alvarez, C. Sánchez-Sánchez, M .F. López, J. Mendez and <u>J.A. Martin-Gago</u> Instituto de Ciencia de Materiales de Madrid, Spain “Structure and self-organization of organic and bio molecules on single crystal Surfaces”	<b>5ETCHC Invited 07</b> <u>Philippe Steyer</u> , A. Mege, G. Thollet, C. Esnouf, Laboratoire de Physico-Chimie Industrielle, INSA de Lyon, France “How to design nanostructured PVD nitrides based coatings for increasing the durability of steel?”
12h00m	<b>7IVM Invited 06</b> <u>Nuno Peres</u> , Department of Physics, Universidade do Minho, Portugal “The electronic properties of graphene”	<b>5ETCHC Invited 08</b> F.A. Almeida, A.J.S. Fernandes, F.J. Oliveira and <u>R.F. Silva</u> , Ceramics & Glass Eng. Dept. University of Aveiro, Portugal “Semi-Orthogonal Cutting of Hardmetal with CVD Diamond at Different Rake Angle”
12h40m	<b>7IVM Oral 13</b> <u>V.Vassilenko</u> , H.Marques, O.M.N.D.Teodoro and . A.M.C. Moutinho “Formation and thermal stability of monolayer and multilayer films by azidoacetonitrile decomposition onto rhodium surfaces”	<b>7IVM Oral 04</b> V. Rachpech, <u>J.F. Pierson</u> , S. Weber and A. Billard “Effect of air annealing on the structure and the hardness of Cr-Si-N coatings deposited using a hybrid arc-magnetron process”
13h00m	<b>Lunch</b>	

Tuesday Afternoon		
	7 <sup>th</sup> IVM	5 <sup>th</sup> ETCHC
14h20m	<b>Poster session</b>	
16h00m	<b>Coffee break</b>	
16h20m	<b>Excursion</b>	
20h00m	<b>Conference dinner</b>	

Wednesday Morning		
	7 <sup>th</sup> IVM	5 <sup>th</sup> ETCHC
9h00m	<b>Plenary session 5.</b> Marcel Rost, Kamerlingh Onnes Laboratory, Leiden University, The Netherlands "In-situ, Real-time Observation of Thin Film Deposition: Roughening, Zeno, Grain Boundary Crossing Barrier, and Steering"	
10h00m	<b>7IVM Invited 07</b> <u>Jatin K. Rath</u> , SID-Physics of Devices, RvdG Laboratory, Utrecht University, The Netherlands "In-situ diagnostics in VHF PECVD process : A crucial aspect for fast fabrication of thin film silicon solar cells"	<b>5ETCHC Invited 09</b> <u>Rafael Rodriguez</u> , AIN-Centro de Ingeniería Avanzada de Superficies, 31191 Cordovilla, Pamplona, Spain "New trends in decorative and functional coatings"
10h40m	<b>7IVM Oral 12</b> <u>Eduardo Alves</u> , Nuno Barradas, F. Munnik, Teresa Monteiro, Marco Peres, Jinzhong Wang, Rodrigo Martins and Elvira Fortunato "Structural and optical properties of nitrogen doped ZnO films"	<b>5ETCHC Oral 05</b> <u>J. A. García</u> , Ibon Azkona, J. Fernandez de Larriona, M.J. Diaz de Cerio, R. Martinez 1, R. J. Rodríguez , R. Escobar and J.M. Albelia "Oxidation behaviour of CrAlN, AlTiN and noncomposite coatings"
11h00m	<b>Coffee break</b>	
11h20m	<b>7IVM Invited 08</b> <u>Olinda Conde</u> , Nicoleta Popovici and M. Luísa Paramés, Department of Physics, Universidade de Lisboa, Portugal "Pulsed Laser Deposition of Oxide-based thin films for spintronics"	<b>5ETCHC Oral 06</b> <u>C. Louro</u> : J.C. Oliveira, N.M.G. Parreira and A. Cavaleiro "Effect of O Addition on the Thermal Behaviour of Hard W-N Sputtered Coatings"
11h40m		<b>5ETCHC Oral 07</b> <u>B. Skoric</u> , D. Kakas, A. Miletic and G. Favaro "The Nano Modification of Duplex Hard Coatings with Nitrogen Ion Implantation"
12h00m	<b>Plenary session 6.</b> Akhlesh Lakhtakia, Pennsylvania State University, University Park, USA "Elastodynamics of Inorganic and Polymeric Sculptured Thin Films"	
13h00m	<b>Lunch &amp; Conference ends</b>	

**Plenary Speakers:**

1. **J.L. de Segovia**, Instituto de Ciencia de Materiales de Madrid (former IUVSTA President), Spain  
"History of Vacuum"
2. **Guglielmo Fortunato**, Flexidis and IMM- CNR, Italy  
"Low temperature polysilicon TFTs on polyimide substrates for flexible electronics"
3. **Ron Naaman**, The Weizmann Institute of Science, Israel  
"Cooperative Molecular Field Effect- A Source for New Electronic Properties at Interfaces"
4. **Geoff Thornton**, London Centre for Nanotechnology, University College London, UK  
"Nanoscale science on metal oxide surfaces"
5. **Marcel Rost**, Kamerlingh Onnes Laboratory, Leiden University, The Netherlands  
"In-situ, Real-time Observation of Thin Film Deposition: Roughening, Zeno, Grain Boundary Crossing Barrier, and Steering"
6. **Akhlesh Lakhtakia**, Pennsylvania State University, University Park, USA  
"Elastodynamics of Inorganic and Polymeric Sculptured Thin Films"

**Invited speakers — 5<sup>th</sup> Iberian Vacuum Meeting:**

1. **Pierre Jamoton**, Facility Department, Low Temperatures Laboratory, Centre Spatial de Liege, Université de Liège  
"Planck Cryogenic Testing in CSL Premises, Helium Partial Pressure Management"
2. **Wolfgang Jitschin**, University of Applied Sciences Giessen-Friedberg, Germany  
"Precise flow measurement of arbitrary gas species over a wide range"
3. **Lluis Miralles**, CELLS Engineering Division, Barcelona, Spain  
"ALBA Spanish Synchrotron Light Source- Vacuum System Status"
4. **João Pedro Conde**, Department of Chemical and Biological Engineering, Instituto Superior Técnico, Lisbon, Portugal  
"Thin-film silicon MEMS"
5. **Jose A. Martín Gago**, Instituto de Ciencia de Materiales de Madrid, Spain  
"Structure and self-organization of organic and bio molecules on single crystal Surfaces"
6. **Nuno Peres**, Department of Physics, Universidade do Minho, Portugal  
"The electronic properties of graphene"
7. **Jatin K. Rath**, SID-Physics of Devices, RvdG Laboratory, Utrecht University, The Netherlands  
"In-situ diagnostics in VHF PECVD process : A crucial aspect for fast fabrication of thin film silicon solar cells"
8. **Olinda Conde**, Department of Physics, Universidade de Lisboa, Portugal  
"Pulsed Laser Deposition of Oxide-based thin films for spintronics"

**Invited speakers — 5<sup>th</sup> European Topical Conference on Hard Coatings Vacuum Meeting:**

1. **Rámon Escobar Galindo**, Autonoma University of Madrid, Spain  
"Advanced characterisation of nanometer multilayers: depth profiling comparison of RBS, SIMS, XPS and GDOES"
2. **Luis Rebouta**, Department of Physics, Universidade do Minho, Portugal  
"Superhard nanostructured coatings: structure and properties relations"
3. **Tomas Polcar**, University of Coimbra, Portugal  
"Transition metal dichalcogenides alloyed with carbon: a new class of self-lubricating coating"
4. **Johan Böhlmark**, CEO Chemfilt Ionspattering AB Linköping, Sweden  
"High Power Impulse Magnetron Sputtering – an overview of history, properties and current status"
5. **Wolfgang Diehl**, Fraunhofer-Institut für Schicht- und Oberflächentechnik, Braunschweig, Germany  
"Hard coatings produced by plasma processes – technology and recent applications"
6. **Fabien Bénédic**, Laboratoire d'Ingénierie des Matériaux et des Hautes Pressions, CNRS, Université Paris 13, France  
"Nanocrystalline diamond films: from growth to applications"
7. **Philippe Steyer**, Laboratoire de Physico-Chimie Industrielle, INSA de Lyon, France  
"How to design nanostructured PVD nitrides based coatings for increasing the durability of steel?"
8. **Rui Silva**, Ceramics & Glass Eng. Dept. University of Aveiro, Portugal  
"Semi-Orthogonal Cutting of Hardmetal with CVD Diamond at Different Rake Angle"
9. **Rafael Rodriguez**, AIN-Centro de Ingeniería Avanzada de Superficies, 31191 Cordovilla, Pamplona, Spain  
New trends in decorative and functional coatings